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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/684,079	10/09/2003	Christopher Bencher	AMAT/2966.C1/DSM/BCVD/JW 3052 EXAMINER	
44257 7	590 08/10/2005			
MOSER, PATTERSON & SHERIDAN, LLP			YEVSIKOV, VICTOR V	
APPLIED MATERIALS, INC. 3040 POST OAK BOULEVARD, SUITE 1500			ART UNIT	PAPER NUMBER
HOUSTON, TX 77056			2891	

DATE MAILED: 08/10/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Application No. Applicant(s) SUPPLEMENTAL 10/684,079 BENCHER ET AL Notice of Allowability Examiner Art Unit Victor V. Yevsikov 2891 -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to <u>PAPER, FILED 10/09/2003</u>. 2. The allowed claim(s) is/are 1-29. 3. The drawings filed on <u>09 October 2003</u> are accepted by the Examiner. 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) 🗌 Ali b) Some* c) None of the: Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. 🗌 A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) Including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) I including changes required by the attached Examiner's Amendment / Comment or in the Office action of Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. Attachment(s) 1. Notice of References Cited (PTO-892) 5. Notice of Informal Patent Application (PTO-152) 2. Notice of Draftperson's Patent Drawing Review (PTO-948)

3. 1 Information Disclosure Statements (PTO-1449 or PTO/SB/08),

Examiner's Comment Regarding Requirement for Deposit

Paper No./Mail Date 01/26/04

of Biological Material

 Interview Summary (PTO-413), Paper No./Mail Date _

9.
Other _____.

7. Examiner's Amendment/Comment

8. X Examiner's Statement of Reasons for Allowance

Application/Control Number: 10/684,079

Art Unit: 2891

DETAILED ACTION

Allowable Subject Matter

Claims 1-29 are allowed.

The following is an examiner's statement of reasons for allowance:

Prior art does not teach a method of processing a substrate, wherein depositing a silicon carbide barrier layer, a silicon carbide material (anti-reflective coating) and a silicon carbide etch stop and wherein the silicon carbide material has a dielectric constant of less than about 5 and has a reflectivity of about 7 percent or less at ultraviolet wavelengths, and depositing a photoresist layer adjacent the etch stop.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Victor Yevsikov whose telephone number is (571) 272-1910. The examiner can normally be reached on Monday –Thursdays 8:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, examiner's supervisor, William B. Baumeister, can be reached on (571) 272-1722. The fax phone numbers for the organization where this application or processing is assigned is (703) 873-9306.

Art Unit: 2891

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published application may be obtained from either Private PAIR or Public PAIR. Status information for unpublished application is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

May 2, 2005

Victor Yevsikov Examiner

B. WILLIAM BAUMEISTER SUPERVISORY PATENT EXAMINER